

**Notice of References Cited**

Application/Control No.

09/821,027

Applicant(s)/Patent Under  
Reexamination  
CHEN ET AL.

Examiner

Michelle Crowell

Art Unit

1763

Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-6,095,159	08-2000	Blalock et al.	134/1.1
	B	US-6,252,354	06-2001	Collins et al.	315/111.51
	C	US-6,414,648	07-2002	Holland et al.	343/895
	D	US-6,319,355	11-2001	Holland, John Patrick	156/345.48
	E	US-6,174,450	01-2001	Patrick et al.	216/61
	F	US-5,935,373	08-1999	Koshimizu, Chishio	118/7231
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N	JP 11144894 A	05-1999	Japan	OKUMURA et al.	H05H 01/46
	O	JP 40805998 A	02-1996	Japan	Takahashi et al.	H05H001/46
	P					
	Q					
	R					
	S					
	T					

**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	W	
	X	

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.